IFW



PATENT Attorney Docket No. 0553-0378

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Shunpei Yan	nazaki, et al.)	I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Serial No.: 10/664,642		Commissioner for Patents P.O. Box 1450
Filed: September 19, 2003		Alexandria, VA 22313-1450
Examiner: Stanettta	D. Isaac)	DATE: November 5, 2004 NAME: Christine A. Barglik
Art Unit: 2812)		SIGNATURE: Churtus a. Buglik
For: FABRICAT	ION SYSTEM AND)	
MANUFAC	TURING METHOD OF)	
LIGHT EMI	TTING DEVICE)	

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT A

Dear Examiner:

We are in receipt of the Office Action dated October 5, 2004, and the following remarks are made in light thereof.